

A multi-well structure of light-addressable potentiometric sensor for measurement of a plurality of liquid samples

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Simultaneous measurement of a plurality of analytical samples in a single step is advantageous for reduction of time and cost of laboratory assays. The light-addressable potentiometric sensor (LAPS) [1] offers a platform to integrate a large number of measurement spots on a single sensor plate, which can be accessed by addressing light beams. In this study, we developed a partially-etched structure [2] of LAPS, in which each of the etched region serves as a defined well to accommodate a liquid sample and produces larger photocurrent signals in a wider frequency bandwidth.

Figure 1 illustrates the measurement setup for a plurality of liquid samples on a LAPS sensor plate with a multi-well structure. The structure was fabricated by anisotropic etching of a 200- μm -thick n-type Si (100) substrate with TMAH. As a pH-sensitive surface, a 130-nm-thick SiO_2 layer was formed on the front surface. Thin layers of Ti/Au film were evaporated as ohmic contacts at two edges, where the SiO_2 film was partially removed by 5% HF using a photolithographically patterned resist. Each well could be loaded with 2 - 4 μL of liquid sample contacted with a platinum wire coated with Ag/AgCl. A modulated light beam was used for addressing the wells one by one.

Buffer solutions with pH 1 to 9 were poured into wells 1 to 9, and their potential responses calibrated with their responses to a pH 7 buffer solution were plotted in Figure 2, which showed a pH sensitivity of about 32 mV/pH.

The advantage of the proposed sensor plate in term of its performance and its applicability to biological samples will be discussed in the presentation.

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[1] D. G. Hafeman, et al., Science 240, pp.1182-1185, 1988.

[2] H. Truong, et al., *EnFI 2017*, Marburg, Germany, 28–29 August, 2017.

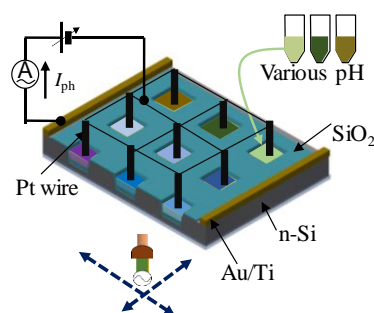


Fig. 1 Schematic of multi-well sensor based on a partially etched structure.

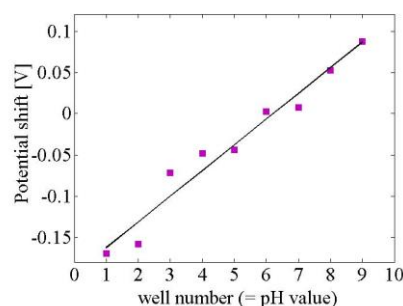


Fig. 2 The bias voltage shift depending the pH value at different wells.